

TJK/408

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of) ATOMIC LAYER DEPOSITION
Hwang et al.) METHOD AND SEMICONDUCTOR
Application No.) DEVICE FABRICATING
Filing Date:) APPARATUS HAVING ROTATABLE
) GAS INJECTORS
) Group Art Unit:
)
Examiner:

Commissioner for Patents
P.O. Box 1450
Mail Stop: Divisional Patent Application
Alexandria, VA 22313-1450

REMARKS

Applicant hereby requests that prosecution of this application proceed on claims 1-3. In view of the foregoing amendmens, Applicant submits that the present application is now in condition for allowance. An early allowance of the application is earnestly solicited.

Date: 8/18/03

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Respectfully submitted,

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I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450. Timothy J. Keefer